| Stort | Room 1 | | | |
|------------------------|--|--|--|--|
| Start | Hall B (3F) Opening Ceremony | | | |
| Keynote speech 1 Title | | | | |
| | Keynote speech 2 | Author(s) Title | | |
| Author(s) | | | | |
| | Coffee Break Keynote speech 1 Title | | | |
| Author(s) | | | | |
| | Keynote speech 2 Title Author(s) | | | |
| | | Lunc 12:00-1 | | |
| | Room 1 | Room 2 | Room 3 | Room 4 |
| | Hall B (3F) | 301 (3F) | 302 (3F) | 401 (4F) |
| | Finishing, lapping, polishing and deburring I | CMP and semiconductor wafer processing I | Applications of data science in manufacturing / Machine tools and systems, tooling I | Surface integrity and materials characterization |
| | O\$10 | OS5 | O\$21/O\$15 | O\$18 |
| 13:00 | Research on process parameter optimization of ultrasonic polishing of zirconia ceramics based on Fresnel-structured transducer | Towards accurate CMP simulations: Bridging experimental data and numerical models for SiC wafers | Intelligent and sustainable laser micro/nano additive manufacturing technologies | The evolution of gradient microstructure on the thread root of 300M steel during surface rolling process |
| | Mengkuan Zhao, Ming Feng, Xianglei Zhang, Baiyi Chen, Sisi Li | Roberto Iaconi, Riku Tanaka, Kevin Richard G. Operiano, Susumu Maeda, Fumiya Kawate, Saeed Sepasy, Yoshifumi Watanabe | Ming-Tsang Lee | Hongwei Liu, Renke Kang, Xianglong Zhu, Haotian Mu |
| 13:20 | A novel finishing method of micro holes with high aspect ratio by abrasive flow polishing | Study of technology for fine conditioning of pad surfaces with fiber conditioner in CMP | Performance comparison of single- channel and dual-channel G-sensor data for tool state recognition using deep learning | CF/PEKK and CF/PPS compared to |
| | Nien-Tien Cheng, Hai-Ping Tsui, A-Cheng Wang, Yan-Cherng Lin | Haruki Hashimoto, Takashi Fujita, Yuki Arai | Min-Chieh Chen, Yue-Feng Lin, Ming-Yi Tsai, Ting-Hsueh Chuang | Xunxun Zhang, Jielin Chen, Qinglong An, Weiwei Ming, Ming Chen |
| 13:40 | Wiceliamstic study of metion | Application of a Photocatalytic Polishing-Capable Grinding Wheel for Surface Preparation of SiC Wafers Prior to CMP | Development of Reinforcement learning Framework for Self- Optimization of Machining Parameters | |
| | Tao Wu, Min Wu, Hui Huang | Lian Hong-Hui, Chen Kai-Jung, Wang Yu-Chen, Tsai Ming-Yi | Libo Zhou, Toshihiro Komatsu, Yusuke Morishita, Hirotaka Ojima, Huapan Xiao, Jiaming Zhan, Wei Hang, Jun Zhao, Dekui Mu, Han Huang | Ming Lu |
| 14:00 | Research on High-Efficiency Polishing of Gallium Nitride N-Face with Sol-Gel Polishing Films | Development of Eco-Friendly Functionalized TiO ₂ Photocatalytic Slurry for Enhanced Performance in Single- Crystal Silicon Carbide Wafer Chemical Mechanical Polishing | An identification method of position-independent geometric errors in the rotary axes of five-axis machine tools | Fracture and acoustic emission analysis of three-layer SiCf/SiC composite |
| | Yikun Hu, Jing Lu | Kuo-Jen Hsu, Kai-Jung Chen, Min- Gyi Tsai | Huanlao Liu, Li Xiang, Wang Yulin, Dai Xin | Jingguo Zhou, Bin Lin, Pengcheng Zhao, Tianyi Sui |

| | | Effects of Femtosecond Laser Surface Modification on Structural Changes of 4H-SiC Wafers | Development of grinding spindle with active control system using hydraulic servo valve | Numerical Analysis of Notch Effects Under Varying Hole Depths on Blanking Machining of Amorphous Alloys |
|-------|---|---|--|--|
| | Yohei Hashimoto, Rika Noda, Minoru Ito, Tetsuya Yamada | Yi-Han Chen, Kai-Jung Chen, Ming- Yi Tsai, Yen-Liang Yeh | Rinta Tanaka, Shumon Wakiya, Dmytro Fedorynenko, Yohichi Nakao, Takumi Kurosu, Yusuke Suzuki | Jianjie Yuan, Chieko Kuji, Masayoshi Mizutani |
| | | Coffee | Break | |
| | | 14:40-1 | 5:10 | |
| | Finishing, lapping, polishing and deburring II | CMP and semiconductor wafer processing II / Applications of abrasive technologies / High speed and high-efficiency machining | Machine tools and systems, tooling II | Tribology in manufacturing |
| | O\$10 | O\$5/O\$6/O\$13 | O\$15 | O\$19 |
| 13.10 | Molecular dynamics simulation and experimental study of CVD diamond graphitization during laser polishing process | Study on Abrasive-Free Buff Polishing of GaN Substrates | Virtual commissioning and machine improvement of optical glass lens centering process based on digital twin technology | Evaluation of Solid Lubricity of Aluminum Alloy SurfacesTextured by Vibration-assisted Cutting |
| | Haojie Zhu, Fanghong Sun | Muhammad Zaim Iqbal Bin Mohd Faizal, Yuya Watanabe, Junichi Ikeno, Yohei Yamada, Tatsuya Shikano, Takeru Abe, Yasushi Hongo, Toshimasa Mano | Chia-Chi Chang, Wei-Han Chen, Yu-Chen Liang, Ke-Er Tang, Yu-Zhen Mao, Chun-Wei Liu | Kaito Kunitan, Jun Shimizu, Takeyuki Yamamoto, Teppei Onuki, Hirotaka Ojima, Libo Zhou |
| | Model and experiments of spatial profile of material removal in non- contact shear thickening polishing | Study on the microwave plasma modification-assisted shear-thickening polishing for silicon carbide wafer | Fundamental study on chip control in turning | Investigation of hydration layer strength in molecular dynamics simulation model of silicon CMP |
| | Jun Zhao, Wei Hang, Dekui Mu, Huapan Xiao, Jiaming Zhan, Libo Zhou, Han Huang | Wei Hang, Jun Zhao, De Kui Mu, Hua Pan Xiao, Jia Ming Zhan, Li Bo Zhou, Han Huang | Ryu Kijima, Masahiko Jin | Fumito Suga, Jun Shimizu, Kazuki Kaneko, Teppei Onuki, Hirotaka Ojima, Libo Zhou |
| 15.50 | Material removal mechanism in Fenton based AlN ceramic substrate polishing process | Investigation of material removal distribution at the edges during silicon wafer polishing | Performance of a novel Ti-Ni based diamond wheel for Hard and brittle single crystals Dekui Mu, Guihua Yu, Han | Localized Hydrostatic Pressure- assisted Cutting of Aluminum with a Rolling Element |
| | Liang Zhao, Kaiping Feng, Binghai Lyu | Yuki Tamaki, Yuta Seguchi, Urara Satake, Toshiyuki Enomoto | Huang, Libo Zhou, Jun Zhao, Wei Hang, Huapan Xiao, Jiaming Zhan | Jun Shimizu, Takeyuki Yamamoto, Teppei Onuki, Hirotaka Ojima, Libo Zhou |
| 16:10 | | Machine Learning in Precision Machining of Hard and Brittle Crystal Solids | Tool path compensation for tracking error in fast travelling focused on highly efficient and precise freeform surface machining | Sustainable Tribological Solutions: Ceramic-Coated Shaft Sleeves Optimized through Ultrashort- Pulsed Laser Structuring and Precision Grinding Masih Paknejad, Robert |
| | | Guanwei He, Qingqing Huang, Xinhao Li, Huapan Xiao, Jiaming Zhan, Wei Hang, Jun Zhao, Dekui Mu, Libo Zhou, Han Huang | Sho Sakataya, Masahiko Fukuta | Bösinger, Bahman Azarhoushang, Andreas Kailer, Georg Konrath, Andreas Killinger, Matthias Blum, Tom Pfindel, Esmaeil Ghadiri Zahrani |
| 16:30 | | Effect of stress distribution on subsurface damage occurrence directly below indentation at small load in fused silica | Investigation of monitoring method by spindle motor current during step drilling in multi-spindle drilling machine | Tribological properties of SiC _f /SiC ceramic matrix composites in grinding with different lubrication methods |
| | | Ranto Inoue, Ryutarou Kurakami, Naomichi Furushiro, Daisuke Hirooka, Tomomi Yamaguchi, Katutoshi Sumida, Kenichi Tanada | Atsushi Yamamoto, Makoto Hosaka, Masao Nakagawa, Toshiki Hirogaki | Ben Wang, Hongdi Chu, Qi Zhang, Honggang Yin, Hao Zhang |

| | Finishing, lapping, polishing and deburring III | Abrasive machining I | In-process measurement, monitoring and metrology I | Grinding wheel and abrasive grain technologies I |
|-------|--|--|---|---|
| | O\$10 | O\$1 | O\$14 | O\$12 |
| 8:40 | removal mechanism of SiC irradiated by plasma Yuan Julong, Luo Congyue, Han | Research on Surface Residual Stress in Profile Grinding of Nickel-Based Superalloy K444 Min Li, Xiangyu Huang, Renhao Nan, Ning Qian, Linbo Che, Wenfeng | Grain size distribution evaluating with micro-Raman image on working surface of fine-granularity grindstone Ryo Taguchi, Ryohei Tazawa, Teppei Onuki, Hirotaka Ojima, Jun | Study on the properties of textured grinding wheel and grinding duplicating surface based on biomachining Yu Huang, Hui Huang, Weibin |
| 9:00 | Yunxiao Flow field characteristics and experimental study of quartz glass constrained flow field shear | Ding, Jiuhua Xu Energy partition analysis in the grinding of Inconel-718 superalloy with heat pipe grinding wheel under | Shimizu, Libo Zhou ML-based Cutting Force Estimation Using Motor Command Signals | Shi, Jingyu Song Preparation and Performance of Structured Micro Spherical PCD Grinding Tools for Micro- |
| | rheological polishing Shuqi Wang, Jinhu Wang | MQL condition Chengxiang Li, Ning Qian, Yucan Fu, Fan Jiang, Slawomir Pietrowicz, Xincheng Ma | Taku Hoshiya, Natsuki Meguro, Yasuhiro Kakinuma | structures Machining Kexin Li, Yinghui Ren |
| 9:20 | Anhydros based shear thickening ultra precision polishing of KDP crystal | Reducing Wafer Bow and Warp through Optimized Diamond Grit Arrangement and Grinding Path Design | for milling based on multi-sensor | Mirror-finishing surface grinding technology for SiC substrate using PCD grinding tool with three-dimensional high-density cutting edges |
| | Fangyuan Chen, Linbin Huang, Julong Yuan | Wang Yu-Chen, Tsai Ming-Yi, Lian Hong-Hui | Yawei Zheng, Zhengcai Zhao, Jiuhua Xu | Haruto Konishi, Takashi Fujita, Yuki Izutani, Yasuo Izumi, Junji Watanabe, Jun Nishiyama |
| 9:40 | Effect of chemical action on shear thickening polishing of YAG | Performance Evaluations of Small Electroplated CBN Wheels in Grinding Nickel Alloys | Analysis of Spindle Current Variations During the Wafer Grinding Process | Nanosecond Laser Ablation Mechanism and Surface Microstructuring of CBN Grinding Wheel |
| | Wei Fang, Binghai Lyu | Zhongde Shi, Helmi Attia, Nicola De Palma | Tsai Jung Tsai, Chen Kai Jung, Tsai Ming Yi, Chen Chun Yen, Huang Shou Zheng | Zhipeng Li, Quanli Zhang, Wenfeng Ding, Yucan Fu, Jiuhua Xu |
| | | Coffee I | Break | |
| | 10:00–10:30 | | | |
| | Ultrasonic machining I | Abrasive machining II | In-process measurement, monitoring and metrology II | Grinding wheel and abrasive grain technologies II |
| | O\$9 | O\$1 | O\$14 | O\$12 |
| 10:30 | ultrasonic assisted-coolant | Experimental Investigation of Chatter Vibration Mechanism Based on Variation of Acting Wheel Surface in Cylindrical Plunge Grinding | Process Monitoring of Cylindrical Grinding in Lens Centering Using Acoustic Emission Signals | Effect of Grinding Wheel Bond Type in Quartz Glass Machining Process |
| | Hirofumi Suzuki, Kotaro Kawamura, Tatsuya Furuki, Akinori Yui | Koki Hatachi, Yuki Matsumoto, Hiroyuki Kodama, Kazuhito Ohashi | Tsung-Huan Tsai, Yu-Chen Liang, Shiau-Cheng Shiu, Hung-Tsai Wu, Ta-Hsin Chou, Chun-Wei Liu | Takayuki Hirata, Syogo Shibata, Himeka Okochi, Toshikazu Chida |
| 10:50 | Ultrasonic Vibration Polishing of SiC Wafers | Fabrication and polishing performance of CVD diamond-coated SiC abrasives | In-situ Areal Surface Texture Measurement on Machined Surfaces using Autofluorescence of Lubricating Oil | Evaluation of the Effects of Machining Conditions on the Plastic Pile-up Performance in Single Abrasive Grain Grinding |
| | Thanawan Bunpheng, Hakuto Nakano, Peerapong Kasuriya, Sutasn Thipprakmas, Masahiko Jin | Dongdong Liu, Fanghong Sun | Saeko Fujii, Shuzo Masui, Masaki Michihata, Satoru Takahashi | Gen Uchida, Xun Chen, Juan Ignacio Ahuir-Torres, Alireza Eslami Majd |
| 11:10 | Development and Mechanistic Investigation of Ultrasonic Vibration-Assisted Grinding for 6/8-Inch SiC Wafers | Clarifying the improvement of the machining efficiency by ultrasonic vibration through tip-based single asperity nanoscratching | Evaluation of the state of abrasive grains on the surface of grinding belts using polarization camera features | Study on Performance of High Feed Rate Face Grinding of Cemented Carbide with Cup Type Electroplated Grinding Wheel Takangai Faitheana Shimai |
| | Shou Zheng Huang, Ming Yi Tsai, Tsai Jung Tsai | Hanqiang Wu, Jiang Zeng, Chen Xiao, Yongbo Wu | Seren Omori, Yasutake Haramiishi, Tsuyoshi Shimizu | Takanori Fujiwara, Shimpei Horiguchi, Takashi Onishi, Kazuhito Ohashi |
| 11:30 | Evaluation of Ultrasonic Milling Performance for Ti ₂ AlC MAX Phase Ceramics | A grinding process-microstructure- surface property correlation model for grinding burn mitigation in TPMM35 powder metallurgy high-speed steel | Turret Vibration Monitor with High-Speed Sampling Wireless Communication and Diagnosis of turning process with integrated servo information | Thermal effect of cup wheel grinding based on acoustic emission signal |
| | Keisuke Hara, Naoya Yamaguchi, Naofumi Tsuji, Kota Takashima, Hirofumi Kawamura, Yen-Ling Kuo, Makoto Nanko, Hiromi Isobe | Lanyu Shi, Chenguang Wang, Kenan Zhang, Qinglong An, Weiwei Ming, Ming Chen | Yusuke Nozaki, Takamasa Yamamoto, Ryo Matsuda, Kaito Tanaka, Masao Nakagawa, Toshiki Hirogaki | Pengcheng Zhao, Bin Lin, Jingguo Zhou, Tianyi Sui |

| ſ | | Superfinishing of Cr ³⁺ HVOF | | |
|-------|--|---|--|---|
| 11:50 | | coatings using a new generation of | | |
| | | rubber-bonded superabrasive elastic wheels | | |
| | | Iñigo Pombo, José A. Sánchez, Leire | | |
| - | | Godino, Jorge Álvarez, Egoitz Burgo | | |
| | Lunch | | | |
| | | 12:10-1 | 3:00 | |
| | Ultrasonic machining II | Advanced cutting technology | Beam processing and related topics / Additive manufacturing and related topics | EDM and non-traditional machining / Micro/nano- machining |
| | OS9 | OS3 | O\$4/O\$16 | O\$8/O\$17 |
| | Propose of a dual-frequency ultrasonic aspirator based on the Langevin transducer | Study on high accuracy machining of vertical wall | Feasibility study on planarization by electrodeless photoelectrochemical etching with evanescent light | Electrical Discharge Assisted Turning of CFRP under Low Voltage Conditions |
| | Zhicheng Liao, Shibo Zhang, Yanan Zhu, Yongbo Wu | Ishiyama, Takekazu Sawa | Kaito Miyakoda, Naoto Takahashi, Hirofumi Hidai, Sho Itoh, Souta Matsusaka | Hidetake Tanaka, Ryuta Kuboshima, Emir Yilmaz |
| | Investigation on ultrasonic assisted wafer stripping in laser slicing of single crystal SiC ingot | Reducing tool wear in ultra-precision diamond turning using cutting-edge- slipping method with straight-nosed diamond tools | Study on the femtosecond laser processing temperature field simulation of single crystal GaN substrate | Effect on EDM Property by UFB Coolant With Various Gases |
| | Zhuo Chen, Liqi Gong, Linhe Sun, Qiang Wang, Hanqiang Wu, Yongbo Wu | Xiangyu Zhou, Minghan Chen, Linhe Sun, Yongbo Wu | Chuanzhen Huang, Huilai Wei, Zhenyu Shi, Shuiquan Huang, Baosu Guo | Taiki Niimura, Manabu Iwai, Satoshi Anzai, Takayuki Hirata, Shinichi Ninomiya |
| | Skiving performance by ultrasonic vibration-assisted method | An investigation of hybrid dual-pulse- width laser-waterjet machining of monocrystalline silicon carbide | Comparative Study on the Torque Performance of SUS 316L Screws Fabricated by Selective Laser Melting and Conventional Turning | Resistance enhancement mechanism and sustainable drug release of surface modification titanium mandibular drug reservoir |
| | Shinnosuke Takano, Manabu Iwai, Yoshihiro Take, Takayuki Hirata, Shinsuke Uchida, Shinichi Ninomiya | Dalin Guo, Tianpeng Dun, Jun Wang | Shih-Yu Yen, Kai-Jung Chen, Kuo- Tuo Huang, Yue-Feng Lin | Zhiwen Xiang, Chengdong Wang |
| 14:00 | | Gradual Reaming Method for Large- diameter Hole Machining of Multi- layer CFRP/Ti Stacks | Manufactured 17-4 PH Stainless Steel: The Influence of Post- | Exploring the processing parameters on the machining performance in ultrasonic-assisted nanoscratching of the 4H-SiC |
| | | Pengjie Gao, Tai Ma, Haihang Wang, Yongliang Yan, Xiaoyan Fan, Weiwei Ming, Qinglong An, Ming Chen | Xiaoxiao Liu, Juan Ignacio Ahuir Torres, Jackson William Chadwick, Tahsin Tecelli Opoz, Xun Chen | Hingwaih Tsang, Siyu Sun, Jiang Zeng, Hanqiang Wu, Yongbo Wu |
| 14:20 | | Effect of Cryogenic Treatment on 7A09 Aluminum Alloy and Optimization of Process Parameters | Ultrasonic burnishing with a ball end mill on SUS316L | Atomistic study of material removal behavior during ultrasonic vibration-assisted nanoscratching of single-crystal AlN |
| | | Xianguo Yan, Yuhang Liu, Zhi Chen | Tsuyoshi Shimizu, Yasutake Haramiishi, Akira Yoneyama, Atsushi Amemiya | Chen Xiao, Jian Guo |
| 14:40 | | Enhancing Biological Soft Tissue Cutting Processes to Minimize Tissue Damage Ryusei Senda, Urara Satake, Ryutaro Sambe, Toshiyuki Enomoto | | |
| Ì | Coffee Break | | | |
| | 15:00-15:40 | | | |

| | Poster Session (Room 1) 15:40–17:00 | | |
|-----|---|--|--|
| P01 | Enhanced responsiveness in temperature control of built-in motor spindle | | |
| | Haruki Kawanami, Ryota Ishida, Shumon Wakiya, Yohichi Nakao | | |
| P02 | A predictive model for static-dynamic characteristics of hydrostatic guideway and experimental validation | | |
| | Dongyu Tian, Feihu Zhang, Qiang Zhang, Longjiang Zhang, Yunqiang Li | | |
| P03 | A Study on the Magnetic Deburring Method for Hypodermic Needles | | |
| | Yanhua Zou | | |
| P04 | Study on dimensional accuracy and surface finish of fuel nozzle holes in ultrasonic-assisted single-stroke honing | | |
| | Tianyi Zhang, Changyong Yang, Yingying Yuan, Yucan Fu | | |
| P05 | Investigation of Machining Process in Micro-Diameter End Milling of PI Resin Laminated Pressed Plate | | |
| | Mitsuyoshi Nomura, Takamitsu Hanawa, Tatsuya Fujii, Tsunehisa Suzuki | | |
| P06 | Efficiency improvement of finish milling by milling path correction in consideration of surplus sintering on metal additive manufacturing | | |
| | Tatsuya Furuki, Ryo Tanaka, Hiroki Ninomiya | | |
| P07 | Tribological properties of zinc-transferred surface fabricated with fine particle peening | | |
| | Yutaka Kameyama, Hiroaki Yamanishi, Hideaki Sato, Ryokichi Shimpo | | |
| P08 | Application of Generative AI for Data Augmentation and Quality Classification in Ultrasonic-Assisted Grinding | | |
| | Chung-Ying Wang, Hui-Jean Kuo, Wen-Tse Hsiao, Chienyao Huang | | |
| P09 | Refurbishment of Polycrystalline Diamond Tools for Sustainable High-Value Manufacturing | | |
| | Tahsin Tecelli Opoz, Xiaoxiao Liu, Xun Chen, Hiren Kotadia, Helen Elkington, Sundar Marimuthu | | |
| P10 | Enhanced Precision Control of CNC Machine Tool Using a Two-DOF Multivariable Iterative Learning Approach | | |
| | Yulin Wang, Xuechuan Mei, Huanlao Liu, Can Liu | | |
| P11 | Understanding the Deformation Mechanisms of Single Crystal Gallium Nitride in Grinding Mimicked by Nanoscratching | | |
| | Yunpeng Wang, Yueqin Wu, Hui Huang, Xipeng Xu | | |
| P12 | Effect of Fine Titanium Particle Peening on Surface Morphology and Fatigue Properties of SUP12 Spring Steel | | |
| | Ryosuke Yokoyama, Shozo Hirano, Hidekazu Ito, Kazuyoshi Nono, Shoichi Kikuchi | | |
| P13 | Development of an Intelligent CAM System with On-Machine Automatic Deburring Function Study of Tool Path Generation Algorithm for Automatic Deburring | | |
| | Mikio Fujio, Tsubasa Kikuchi, Kentaro Ootsuka, Keisuke Miwa | | |
| P14 | Fabrication of simulated peening scars using laser irradiation patterning and their fatigue properties | | |
| | Tatsuki Itakura, Miu Hayashi, Hiroyuki Akebono, Shoichi Kikuchi | | |
| P15 | Study on prediction of tool breakage by machine learning | | |
| | Nobuhito Yoshihara, Tomoki Katabira, Masahiro Mizuno | | |
| P16 | 3D Characterization of Process-Induced Porosity in SLM-Fabricated Al-Mg-Sc Alloys A Comparison of Serial Sectioning Microscopy and X-ray CT | | |
| | Shinya Morita, Kanta Suzuki, Yuuki Aida, Shoan Mizuno, Shinichi Tomiyama, Norio Yamashita, Hideo Yokota | | |
| P17 | Research on the Effect of Ultrasonic Vibration-Assisted Laser Percussion Drilling on Micro-hole Morphology | | |
| | Ping Zou, Yaotian Cheng, Yadong Gong, Xuelong Wen | | |